Docket: 145-001US

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Serial No. 10/756627



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ent Application

Inventors: Rene Gerrit Heideman et

Serial No.: 10/756627

Filing Date: 1/13/2004

Art Unit:

2874

Examiner:

Not Yet Assigned

Docket No.: 145-001US

Title:

Low Modal Birefringent Waveguides and Method of Fabrication

Signature

Assistant Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 CFR 1.97(B), the enclosed Information Disclosure Statement, with attached reference(s), is submitted for consideration in the above-identified application.

NO FEE IS REQUIRED.

Pursuant to 37 C.F.R. 1.136(a)(3), please treat this and any concurrent or future reply in this application that requires a petition for an extension of time for its timely submission as incorporating a petition for extension of time for the appropriate length of time.

Respectfully,

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PTO/SB/08 (08-03)

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Substitute for form 1449/PTO				Complete if Known			
Gubstitu	/			Application Number	10/756,627		
INF	ORMATION	N DIS	CLOSURE	Filing Date	1/13/2004		
STATEMENT BY APPLICANT				First Named Inventor	Heideman, Rene		
				Art Unit	2874		
(Use as many sheets as necessary)			ecessary)	Examiner Name	n/a		
Sheet	1	of	1	Attorney Docket Number	145-001US		

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Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		ZHANG, ET AL., Res. Stress Charact. of Thick PECVD TEOS Film for Power MEMS Apps, Proc. Solid-State Sensor and Actuator Workshop, Hilton Head, SC, June 4-8, 2000	
		SMITH, ET AL., Monolithic integration of waveguide structures with surface-micromachined polysilicon actuators, Smart Structures and Materials, Feb. 1996,	
		MCCANN, ET AL., Conformal deposition of LPCVD TEOS, Micro-machining and Micro-fabrication Process Technology, SPIE, Oct. 2001.	
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO:

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